

**Notice of References Cited**

Application/Control No.

10/565,468

Applicant(s)/Patent Under  
Reexamination  
LIU ET AL.

Examiner

BRIAN D. NGUYEN

Art Unit

2472

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0017849	08-2001	Campanella et al.	370/326
*	B	US-2004/0049389	03-2004	Marko et al.	704/260
*	C	US-2004/0008642	01-2004	Marko et al.	370/321
*	D	US-2003/0065823	04-2003	Kim, Paul	709/250
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
	V					
	W					
	X					

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.